Application No. 10/663,631 P Docket No. 740756-2651

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	DEM
Hidekazu MIYAIRI et al.)	Examiner: Felisa Carla Hiteshew
Serial No. 10/663,671)	Group Art Unit: 1722
Filed: September 17, 2003)	-
For: LASER APPARATUS, LASER IRRADIATION)	
METHOD, AND MANUFACTURING METHOD OF)	
SEMICONDUCTOR DEVICE)	

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

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Complete if KHOMENEN Substitute for form 1449A/PTO 10/663,671 Application Number INFORMATION DISCLOSURE September 17, 2003 Filing Date STATEMENT BY APPLICANT Hidekazu MIYAIRI et al. First Named Inventor (use as many sheets as necessary) 1722 Art Unit Felisa Carla Hiteshew **Examiner Name** Sheet 1 of 1 Attorney Docket Number 740756-2651

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where
		Number - Kind Code ² (if known)			Relevant Passages or Relevant Figures Appear
		US-2004/0052279 A1	03/18/2004	MIYAIRI et al.	
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		FO	REIGN PATENT D	OCUMENTS		
Examiner Initials	Cite No. ¹	Foreign Patent Document Kind Code ⁵ Country Code ³ Number ⁴ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Application of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		OTHER PRIOR A	RT – NON PATENT L	ITERATURE DOCUMENTS		
Examiner Initials	Cite No. ¹		r (in CAPITAL LETTERS), title of the article (when appropriate), title of the rnal, serial, symposium, catalog, etc.)., date, page(s), volume-issue number(s), publisher, city and/or country where published.			
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Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.